

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

policant:

L.M. Nicholson et al.

Title:

Improved Chemical Planarization Performance for Copper/Low-k

Interconnect Structures

Filed:

July 28, 2003

Serial No.:

10/628,925

Examiner:

Hung K. Vu

Art Unit:

2811

Docket No.:

YOR920030173US1

Customer No.:

22032

Confirmation No.:

7501

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

Transmitted herewith is Response to the Office Action dated December 30, 2004, in the above-identified application.

Request for extension of time pursuant to 37 C.F.R. §§ 1.136 and 1.137 is hereby made if, and to the extent, required. The fee for this extension of time is calculated to be \$ _____ to extend the time for filing this response until _____ ___. The fee for any change in number of claims has been calculated as shown below.

CLAIMS AS AMENDED							
	Claims Remaining After Amendment		Highest Number Previously Paid	Present Extra	Rate		
Total Claims	31	Minus	50	0	x \$50.00	\$	
Independent Claims	2	Minus	2	0	x \$200.00	\$	
MULTIPLE DEPENDENT CLAIM FEE				x \$360.00 = \$			
TOTAL FEE FOR CLAIM CHANGES				\$0.00			
1/2 FILING FEE FOR SMALL ENTITY						\$N/A	

The total fee for this am time is calculated to be \$0	endment, includ ; acheck for \$	ding claim changes, and	l any extension of	
sheets of amended draw	wings are enclos	sed;		
XXX The Commissioner is he additional fees under 37 C.F.R communication or during the e overpayment, to Deposit Acce	i. §§1.16 and 1. ntire pendency	17 which may be require of the application, or cre	ed with this	
A duplicate copy of this	Form is enclose	ed.		
		Respectfully submitted	d,	
Date: March 30, 2005	By:	Paul D. Greeley Reg. No. 31,019 Attorney for Applicants Ohlandt, Greeley, Rug & Perle, L.L.P. One Landmark Square Stamford CT 06901-2 Tel: 203-327-4500 Fax: 203-327-6401	(s) ggiero e, 10 th Floor	
CEI	RTIFICATE OF	MAILING		
I HEREBY CERTIFY TH WITH THE U.S. POSTAL SER ADDRESSED TO: MAIL STOF P.O. BOX 1450, ALEXANDRIA	VICE AS FIRST AMENDMENT	CLASS MAIL IN AN E COMMISSIONER FO	NVELOPE R PATENTS,	
Vazken A. Alexanian V. Alexanian 3/30/2005 NAME SIGNATURE DATE				
NAME	SIGN	AIUKE	DATE	

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Dear Sir:

In response to the Office Action dated December 30, 2004, please amend this application as follows: